



JPW

AMENDMENT TRANSMITTAL LETTER

Docket No.
FIS920030091US1

Application No.
10/604,146

Filing Date
06/27/03

Examiner
Jack S. J. Chen

Art Unit
2813

Applicant(s): **Joel P. DeSouza et al.**

Invention: **SIMOX METHOD OF MAKING A BURIED OXIDE LAYER USING BASE IMPLANT AND ROOM TEMPERATURE IMPLANT**

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	10	20	0		
Independent Claims	1	- 3	0		
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					

Large Entity

Small Entity

No additional fee is required for this amendment.

Please charge Deposit Account No. _____ in the amount of \$ _____.
A duplicate copy of this sheet is enclosed.

A check in the amount of \$ _____ to cover the filing fee is enclosed.

Payment by credit card. Form PTO-2038 is attached.

The Director is hereby authorized to charge and credit Deposit Account No. **09-0458**
as described below. A duplicate copy of this sheet is enclosed.

Credit any overpayment.

Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

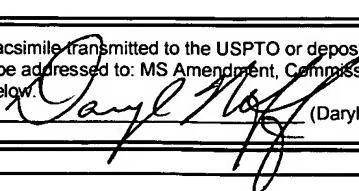
Daryl K. Neff

Attorney Reg. No.: **38,258**

Dated: **May 9, 2005**

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: May 9, 2005

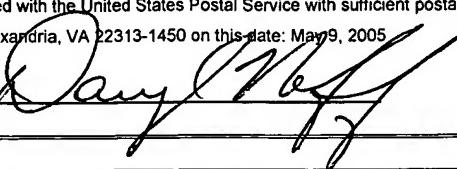
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Name of Depositor: Daryl K. Neff

Signature 

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Joel P. DeSouza et al.	Date: May 9, 2005
Serial Number: 10/604,146	Examiner: Jack S. J. Chen
Filed: June 27, 2003	Group Art Unit: 2813
Title: SIMOX METHOD OF MAKING A BURIED OXIDE LAYER USING BASE IMPLANT AND ROOM TEMPERATURE IMPLANT(Amended)	H. Daniel Schnurmann IBM Corporation Dept. 18G, B/321, Zip 482 2070 Route 52 Hopewell Junction, NY 12533

AMENDMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 8, 2005, Applicants submit the following amendments and remarks for the Examiner's consideration.

Title of the Invention

Please amend the Title to read:

SIMOX METHOD OF MAKING A BURIED OXIDE LAYER USING BASE
IMPLANT AND ROOM TEMPERATURE IMPLANT